

06-25-09

DFW



Docket No.: 01641/0204258-US0  
(PATENT)

**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

In re Patent Application of:  
Karl-Heinz SCHUSTER et al.

Application No.: 10/596,626

Confirmation No.: 8534

Filed: September 15, 2006

Art Unit: 2873

For: MICROLITHOGRAPHY PROJECTION  
OBJECTIVE WITH CRYSTAL LENS

Examiner: E. A. Lester

**RESPONSE TO NON-FINAL OFFICE ACTION**

MS Amendment  
Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

**INTRODUCTORY COMMENTS**

Dear Sir:

In response to the Office Action dated April 15, 2009, please consider the following remarks:

**Amendments to the Specification** begin on page 2 of this paper.

**Remarks/Arguments** begin on page 3 of this paper